

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/769,776	<b>Applicant(s)/Patent under Reexamination</b> SHIBA, KENICHI
	<b>Examiner</b> W. Patty Chen	<b>Art Unit</b> 2871

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
361	681	1/2/2008	WPC
349	58-60	1/2/2008	WPC
see attached EAST search history printout		1/2/2008	WPC